Title: VACUUM INSULATING DOUBLE VESSEL AND METHOD FOR MANUFACTURING THE SAME By: Takafumi FUJII, et al. Docket No.: 040173



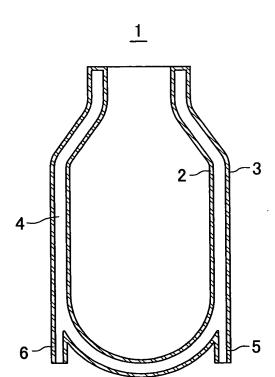
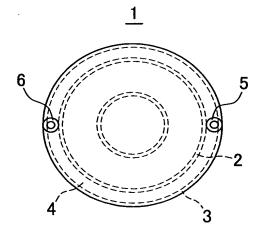


FIG.2



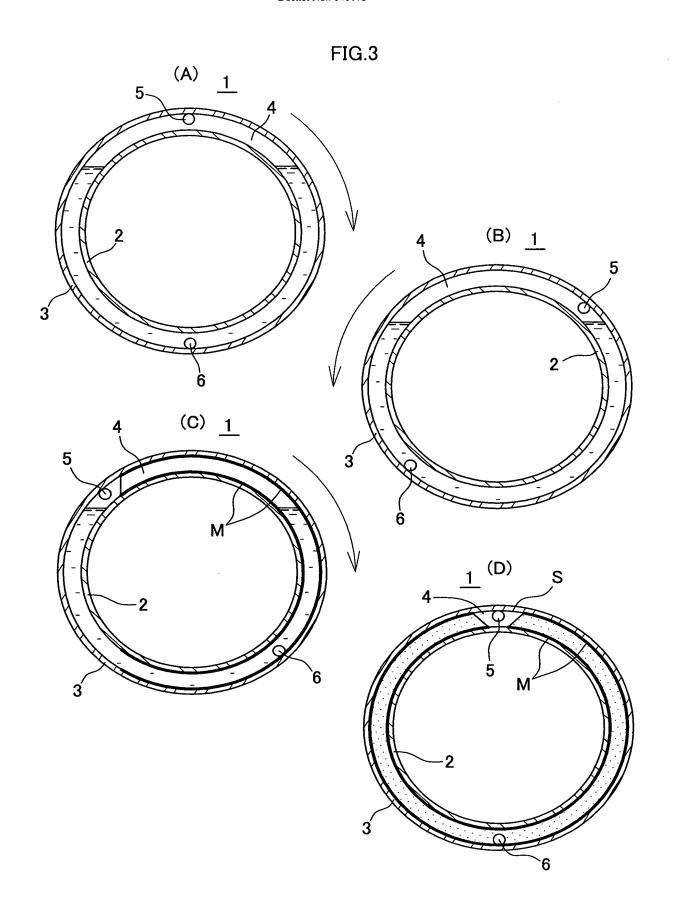


FIG.4

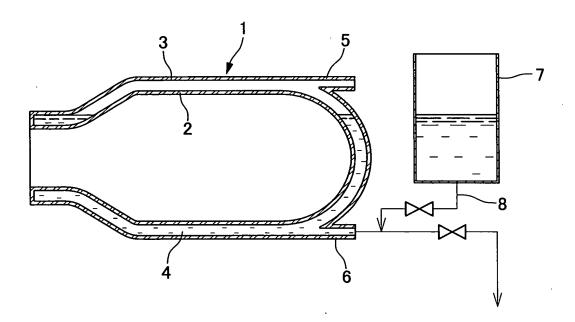


FIG.5

<u>10</u>

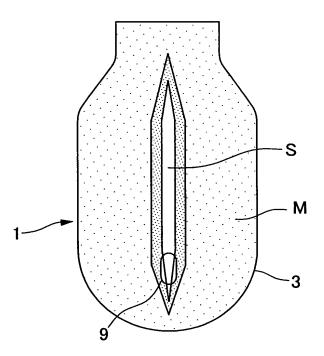


FIG.6

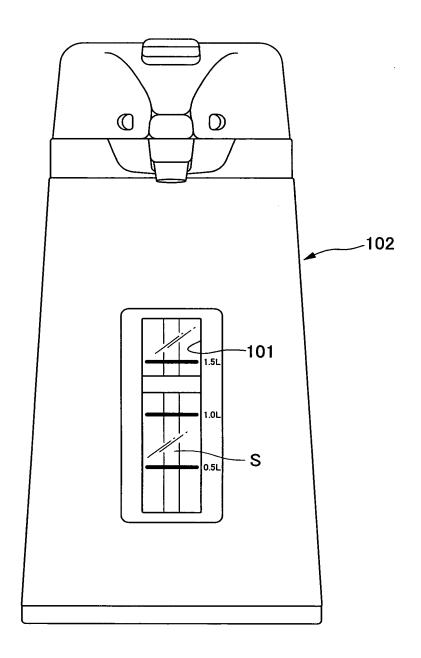


FIG.7

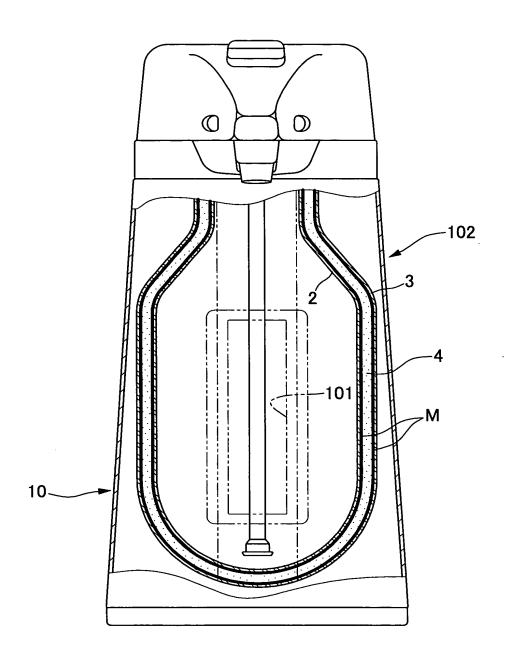


FIG.8

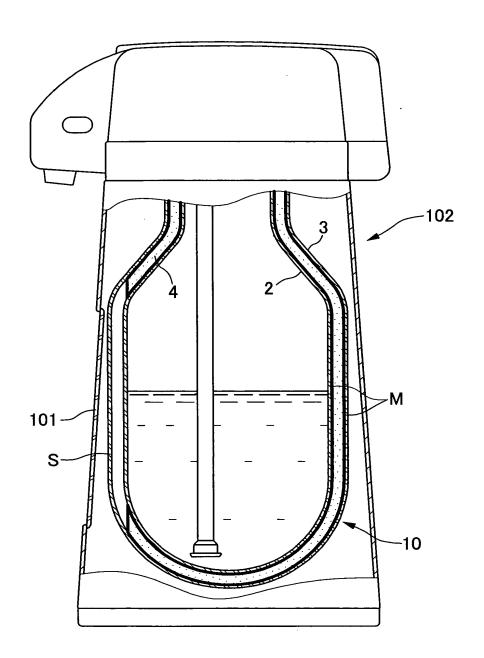


FIG.9

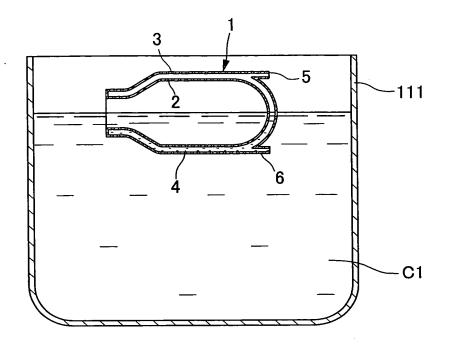


FIG.10

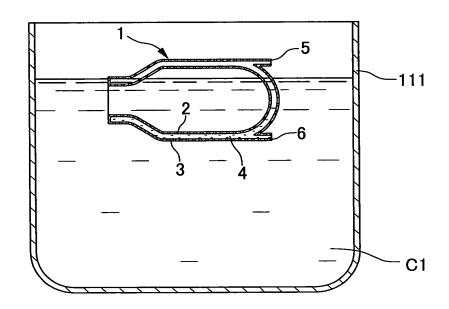


FIG.11

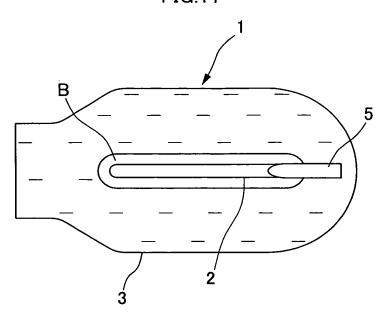


FIG.12

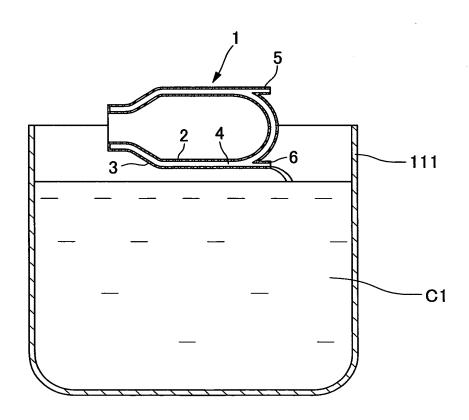


FIG.13

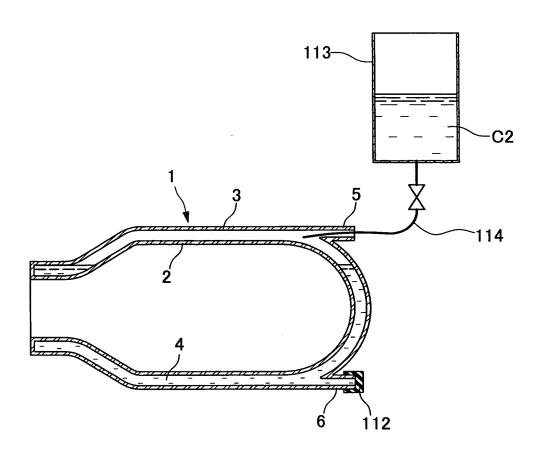


FIG.14

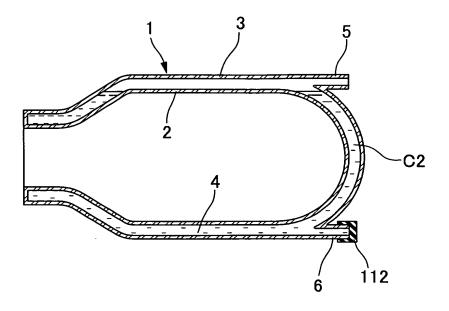


FIG.15

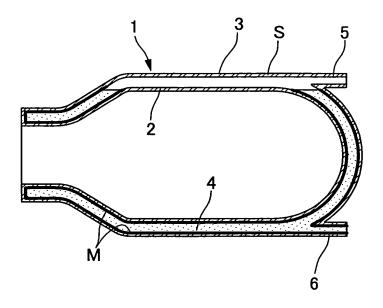


FIG.16

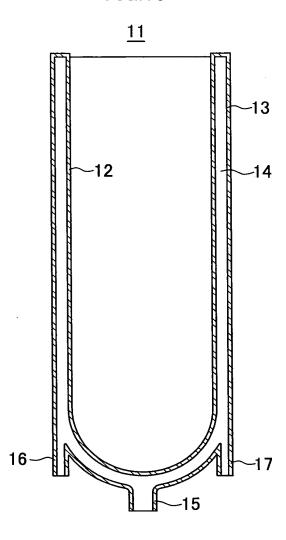


FIG.17

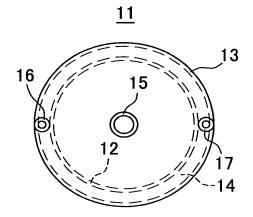


FIG.18

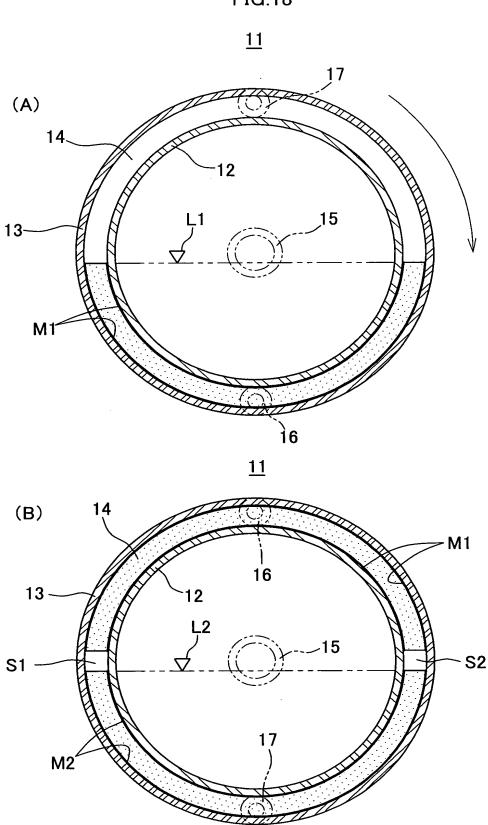
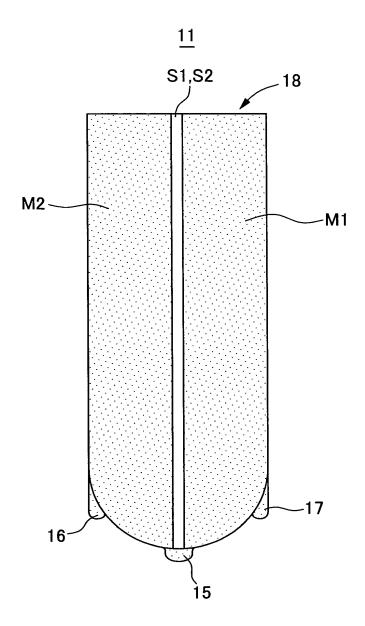
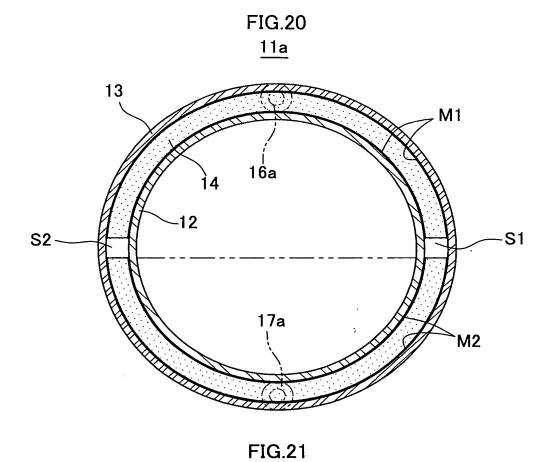


FIG.19





'n

11a 13 M1 12 14 S2 16a S1 M2

FIG.22

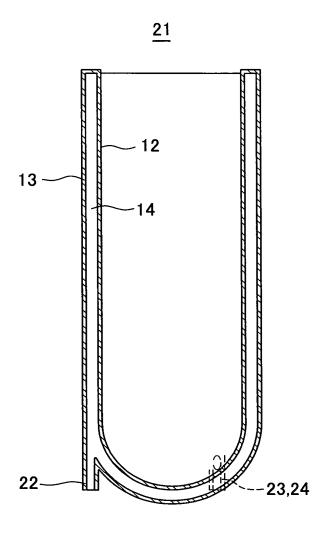


FIG.23

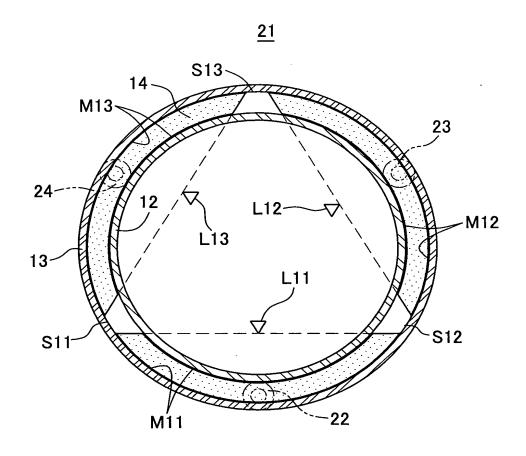


FIG.24

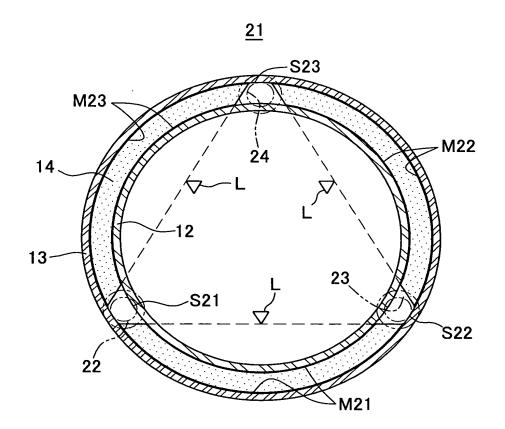


FIG.25

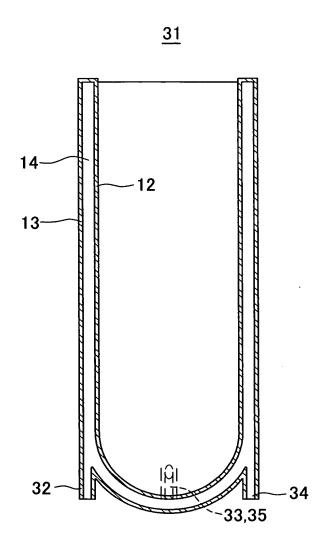


FIG.26

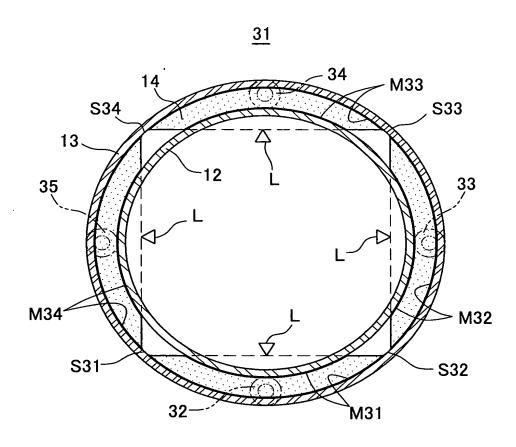


FIG.27

<u>31</u>

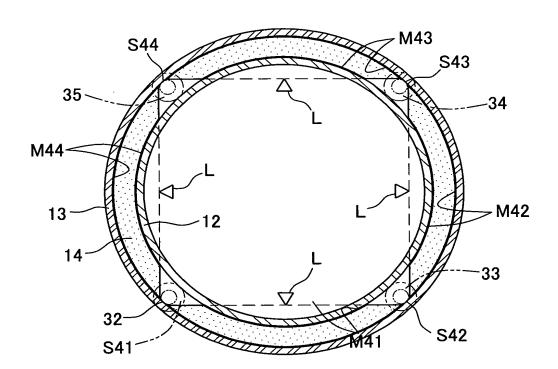


FIG.28

